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IFW/JK



Appl. No. 10/683,801

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/683,801
Filing Date October 10, 2003
Inventor..... Paul A. Morgan
Assignee..... Micron Technology, Inc.
Group Art Unit..... 2812
Examiner Nguyen, H.
Attorney's Docket No. MI22-2411
Title: Methods of Cleaning Surfaces of Copper-Containing Materials, and Methods of
Forming Openings to Copper-Containing Substrates

RESPONSE TO JULY 29, 2004 OFFICE ACTION

To: MS Amendment
Commissioner for Patents
P.O. Box 1450
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AMENDMENTS

Introductory Comments

In reply to the Office Action of July 29, 2004, applicant remarks as follows.